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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Wen-Jian LIN

Group Art Unit:

Serial No.: **10/807,128**

Examiner:

Filed : **March 24, 2004**

For : **OPTICAL INTERFERENCE DISPLAY PANEL AND
MANUFACTURING METHOD THEREOF**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.56 and in accordance with applicant's duty of disclosure, applicant submits a document which the Examiner may find relevant to the examination of the application. A copy of the document is enclosed, along with a listing on PTO Form 1449.

Respectfully submitted,

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May 12, 2004

INFORMATION DISCLOSURE CITATION

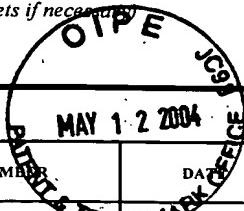
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Docket Number (Optional)
A-8998

Application Number

Applicant(s)
Wen-Jian LIN

Filing Date



U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

| REF | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | Translation | |
|-----|-----------------|------|---------|-------|----------|-------------|----|
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OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

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EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.